

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
BEFORE THE BOARD OF PATENT APPEALS AND INTERFERENCES

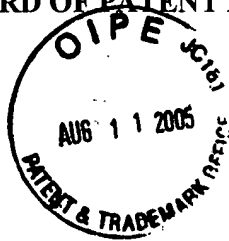
In re Patent Application of:

Morita, E.

Application No. 09/726,860

Filed: November 30, 2000

For: METHOD OF MANUFACTURING
CRYSTAL OF III-V COMPOUND OF THE
NITRIDE SYSTEM, CRYSTAL SUBSTRATE OF
III-V COMPOUND OF THE NITRIDE SYSTEM,
CRYSTAL FILM OF III-V COMPOUND OF THE
NITRIDE SYSTEM, AND METHOD OF
MANUFACTURING DEVICE



Group Art Unit: 1765

Examiner: Anderson, M. A.

I hereby certify that this document is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 8, 2005.

Roxanne M. Swartz
Roxanne M. Swartz

TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed herewith is the Petition to Withdraw Holding of Abandonment of Iwata in the above-identified patent application.

Also enclosed are: Declaration
Copy of previously filed Notice of Appeal
Copy of Return-receipt postcard
Request for Continued Examination (RCE)
Credit Card Payment Form (1 page - in duplicate)
Response to January 10, 2005 Final Office Action
Return Receipt Postcard

The Commissioner is hereby authorized to charge any additional fees required, as well as any patent application processing fees associated with this communication for which full payment has not been tendered, to Deposit Account No. 19-3140. A duplicate copy of this sheet is enclosed.

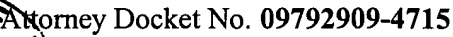
Respectfully submitted,

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Roxanne M. Swartz
Roxanne M. Swartz Date 8/8/05

DECLARATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

I, Paula M. Theismann, attest to the fact that the Notice of Appeal (a copy of which is enclosed) dated July 8, 2005 was deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria VA 22313-1450 on July 8, 2005.

Paula M. Theismann
Paula M. Theismann